- 1) Introduction
- 2) Effects of residual gas (and the vacuum envelope)
 - a) Refractive index fluctuation
 - b) Viscosity and Brownian motion
 - c) Mirror contamination
 - d) Light scattering
- 3) Vessels and beam tubes
 - a) Outgassing of stainless steels
 - b) Conductance and pressure gradients
 - c) Cleaning, bakeout and particulate control
 - d) Structural properties and welding
 - e) Detector interfaces
 - i) Flanges and access
 - ii) Structural support penetrations
 - iii) Light baffles
 - iv) Viewports and instrument feedthroughs
 - f) Preventing, finding, and fixing leaks
- 4) Pumping systems and instrumentation
 - a) Cryogenic traps
 - b) Ion & getter pumps
 - c) Residual gas analyzers
- 5) Instrument construction & preparation
 - a) Detector outgassing constraints
 - b) Qualifying materials and processes
 - c) Electronics in vacuum
 - d) Special techniques
 - i) Encapsulated instruments
 - ii) Differential pumping
 - iii) Ionization and residual charge manipulation
 - iv) Thermal exchange gas